



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Klaus F. Schuegraf et al.

SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING POLYCID
REOXIDATION

Docket No.: 303.278US1
Filed: July 30, 1997
Examiner: Ori Nadav

Serial No.: 08/902,809
Due Date: November 23, 2004
Group Art Unit: 2811

Mail Stop Amendment

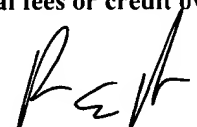
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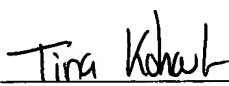
- ☒ A return postcard.
- ☒ An Amendment and Response (9 Pages).
- ☒ A Communication Concerning Related Applications (2 pgs.).

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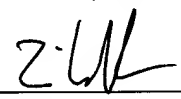
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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
(GENERAL)



8/N 08/902,809

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Klaus F. Schuegraf et al. Examiner: Ori Nadav
Serial No.: 08/902,809 Group Art Unit: 2811
Filed: July 30, 1997 Docket: 303.278US1
Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING
POLYCIDE REOXIDATION

COMMUNICATION CONCERNING RELATED APPLICATION(S)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date</u>	<u>Attorney Docket</u>	<u>Title</u>
10/789890	February 27, 2004	303.278US2	METHOD TO PREVENT METAL OXIDE FORMATION DURING POLYCIDE REOXIDATION
08/902808 5925918	July 30, 1997	303.192US1	GATE STACK WITH IMPROVED SIDEWALL INTEGRITY
09/097353 5998290	June 15, 1998	303.192US2	METHOD TO PROTECT GATE STACK MATERIAL DURING SOURCE/DRAIN REOXIDATION

COMMUNICATION CONCERNING RELATED APPLICATIONS

Serial Number: 08/902,809

Filing Date: July 30, 1997

Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING POLYCIDAL REOXIDATION

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Dkt: 303.278US1

09/323178
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May 28,
1999

303.192US3

SEMICONDUCTOR DEVICES HAVING
GATE STACK WITH IMPROVED
SIDEWALL INTEGRITY

Respectfully submitted,


KLAUS F. SCHUEGRAF ET AL.

By Applicants' Representatives,

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Date 23 November 2004

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